

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/808,321	SAKAI ET AL.	
Examiner		Art Unit	Jason L. Lazorcik	
		1731	Page 1 of 1	

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,823,694	11-2004	Sawada et al.	65/85
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Nomura, T., Yamamoto, Kiyoshi, Nakagawa, N., Mashige, M., "Optical Element Forming Method", Japanese Patent Publication Number: 08-133767, publication date May 28, 1996 (28.05.1997).
	V	Nomura, T., Yamamoto, Kiyoshi, Nakagawa, N., Mashige, M., "Optical Element Forming Method", Japanese Patent Publication Number: 08-133767, publication date May 28, 1996 (28.05.1997) - Machine Translation Accessed (May 7, 2007) ( <a href="http://www4.ipdl.ipit.go.jp/Tokujitu/PAJdetail.ipdl?N0000=60&amp;N0120=01&amp;N2001=2&amp;N3001=H08-133767">http://www4.ipdl.ipit.go.jp/Tokujitu/PAJdetail.ipdl?N0000=60&amp;N0120=01&amp;N2001=2&amp;N3001=H08-133767</a> )
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.